

FORM PTO-1449 INFORMATION DISCLOSURE CITATIONS IN AN APPLICATION			Atty Docket: 58551.US	Serial #:
			Applicant: Patrick Y. Huet et al.	
			Filing Date: 2003.11.19	Group:

U.S. PATENT DOCUMENTS

Examiner Initial	Cite #	Document Number	Date	Name	Class	Sub-Class	Filing Date
------------------	--------	-----------------	------	------	-------	-----------	-------------

FOREIGN PATENT DOCUMENTS

Examiner Initial	Cite #	Document Number	Date	Country	Class	Sub-Class	Translation
------------------	--------	-----------------	------	---------	-------	-----------	-------------

OTHER NON-PATENT DOCUMENTS

Examiner Initial	Cite #	Author, title, date, pertinent pages, etc.
RAR	1	Diebold et al., <i>Handbook of Silicon Semiconductor Metrology</i> , SEMATECH publication, year unknown, pgs 25-30 and relevant figures.

Examiner /Richard Rosenberger/	Date Considered: 02/28/2007
--------------------------------	-----------------------------

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

58551.1449.doc